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## APPLICANTS

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## \*\* CONTINUING DATA \*\*\*\*\*

none / *AKA*

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

*AKA* REPUBLIC OF KOREA 2003-65533 09/22/2003

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 04/28/2004

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged <i>AKA</i> <i>Alankh</i> Examiner's Signature Initials	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 5	TOTAL CLAIMS 41	INDEPENDENT CLAIMS 3
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## TITLE

Etching method for manufacturing semiconductor device

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